

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2811

Examiner: Steven Ho Yin Loke

Serial No.: 10/625,490

Filed: July 22, 2003

In re Application of: Issaq et al.

For: SWITCHING RATIO AND ON-STATE RESISTANCE OF AN ANTIFUSE
PROGRAMMED BELOW 5 mA AND HAING A Ta OR TaN BARRIER
METAL LAYER

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated May 1, 2006, kindly amend the above-identified application as follows.